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PATENT  
Docket No. 20059/PIA31205

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant(s):

**OH, Sang Jun**

U.S. Serial No.: 10/764,905

For: "Methods for Forming an Air  
Gap in a Semiconductor Metal Line  
Manufacturing Process"

Filed: January 26, 2004

Group Art Unit: 1756

Examiner: Not yet Assigned

) I hereby certify that this paper and the  
 ) documents referred to as enclosed  
 ) therewith are being deposited with the  
 ) United States Postal Service as first  
 ) class mail, postage prepaid, in an  
 ) envelope addressed to Commissioner  
 ) for Patents, P.O. Box 1450,  
 ) Alexandria, Virginia 22313-1450 on  
 ) this date:  
 )  
 ) June 8, 2005  
 )  
 )  
 )  
 ) James A. Flight  
 ) Attorney for Applicant(s)  
 ) Registration No. 37,622

STATUS LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced  
matter.

Respectfully submitted,

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June 8, 2005

By:

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